

DATASHEET IQP-700C

IQ+FLOW IQP-700C EPC (P1-control)

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Microfluidic Back Pressure Controllers

Bronkhorst® model IQP-700C Back Pressure Controllers are miniature devices which are ideal for use in cramped environments or in systems requiring minimum internal volume e.g. desktop equipment. The Pressure Controller has a chip-based (MEMS) sensor and is suited for pressure ranges between 0,1...0,5 bar and 2...10 bar absolute or gauge. Communication with the devices can be either in analog mode or digital over RS232 or RS485.

The ultra compact IQ+FLOW instruments are typically recommended for integration in analytical, bioprocessing and medical equipment.

기술 정보

Measurement / control system

절대 압력 센서

Code: 1K5AC (chip sensor) - Ranges (FS): 0,5 ... 1,5 bara - P-max: 3,0 bara
Code: 3K0AC (chip sensor) - Ranges (FS): 1,0 ... 3,0 bara - P-max: 6,0 bara
Code: 10KAC (chip sensor) - Ranges (FS): 3,0 ... 10 bara - P-max: 10 bara
Code: 2K0AS (media-isolated) - Ranges (FS): 0,5 ... 2,0 bara - P-max: 3 bara
Code: 6K0AS (media-isolated) - Ranges (FS): 2,0 ... 6,0 bara - P-max: 10 bara
Code: 10KAS (media-isolated) - Ranges (FS): 3,0 ... 10 bara - P-max: 10 bara

Relative pressure sensors

Code: 1K5GC (chip sensor) - Ranges (FS): 0,5 ... 1,5 barg - P-max: 3,0 barg
Code: 3K0GC (chip sensor) - Ranges (FS): 1,0 ... 3,0 barg - P-max: 6,0 barg
Code: 10KGC (chip sensor) - Ranges (FS): 3,0 ... 10 barg - P-max: 10 barg
Code: 0K6GS (media-isolated) - Ranges (FS): 0,2 ... 0,6 barg - P-max: 1 barg
Code: 2K0GS (media-isolated) - Ranges (FS): 0,5 ... 2,0 barg - P-max: 3 barg
Code: 6K0GS (media-isolated) - Ranges (FS): 2,0 ... 6,0 barg - P-max: 10 barg
Code: 10KGS (media-isolated) - Ranges (FS): 3,0 ... 10 barg - P-max: 10 barg

정확도 (선형도 및 이력현상 포함)

$\leq \pm 0,5 \% FS$
(Based on calibration at ambient temperature)

Repeatability

$\leq \pm 0,2 \% FS$

Pressure rangeability

measurement: 1 : 50 (2...100%)
control: 1 : 5 (with flow range 1 : 50)

Fluids

Chip-sensor : dry, clean, non-flammable and non-corrosive gases. Absolute pressure sensors not suitable for Helium.
Media-isolated sensor : Gases compatible with aluminium or stainless steel SS316L and Viton.

Operating temperature

5 ... 50 °C

Temperature sensitivity

span: 0,1% RD/°C; zero: 0,05% FS/°C

Max. Kv-value

$2,37 \times 10^{-3}$

Leak integrity, outboard

1×10^{-6} mbar-l/s He

Attitude sensitivity

negligible

Mechanical parts

Material (wetted parts)	body : aluminium or stainless steel SS316L; chip sensor (default) : Si, SiOx, epoxy, aluminium; media-isolated sensor (option) : stainless steel SS316L
Process connections	optional: 10-32 UNF threaded internal nut with 1/16" ferrule (SS316 or Peek), 1/16" or 1/8" OD compression type
Seals	FKM/Viton® seals and plunger (default); FKM/Viton® seals and FFKM/Kalrez® plunger (option)
Weight	120 g (Aluminium) / 180 g (SS316L)
Ingress protection	IP40

Electrical properties

Readout sample time	2 msec
Power supply	+15 ... 24 Vdc
Max. power consumption	100 mA
아날로그 출력	0...5 (10) Vdc or 0 (4)...20 mA (sourcing output)
Digital communication	RS232, RS485 (Modbus-RTU/ASCII or FLOW-BUS)

Electrical connection

Power/Analog/RS232/RS485	RJ45 modular jack
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Control valve options

External actuator options to be connected to the controller

Ex-proof specifications

Approvals / certificates

Technical specifications subject to change without notice.

도면 및 배선연결 정보 [제품 페이지](#) 우리의 [웹사이트](#)

Recommended accessories



E-8000 SERIES

디지털 단말기 / 제어 시스템

밝고 넓은 앵글, 1.8" 디스플레이 (TFT 기술)
사용자 친화적인 구동, 4개의 버튼으로 구동되는 메뉴



PIPS SERIES

전원 공급 액세스리

연구실용 / 산업용 제품
메인 연결을 위한 교환 가능한 플러그 (유럽, 영국, 미국, 호주, 국제 전기 표준)

Related products



IQ+FLOW IQPD-700C EPC (P1-CONTROL)

최소 압력 0,1...0,5 bar
최대 압력 2...10 bar
초소형의 컴팩트한 모델; 다운포트
MEMS 기술



IQ+FLOW IQP-600C EPC (P2-CONTROL)

최소 압력 0,025...0,5 bar
최대 압력 0,5...10 bar
초소형의 컴팩트한 모델
MEMS 기술



IQ+FLOW IQP-500C

최소 압력 0,01...0,5 bar
최대 압력 0,2...10 bar
초소형의 컴팩트한 모델
MEMS 기술



IQ+FLOW IQF-200C MFC

최소 유량 범위 0...10 mln/min
최대 유량 범위 0...5 ln/min
압력 범위 10 bar
초소형의 컴팩트 모델
MEMS 기술